

BI Day 2012

The Beam Position System for LINAC4

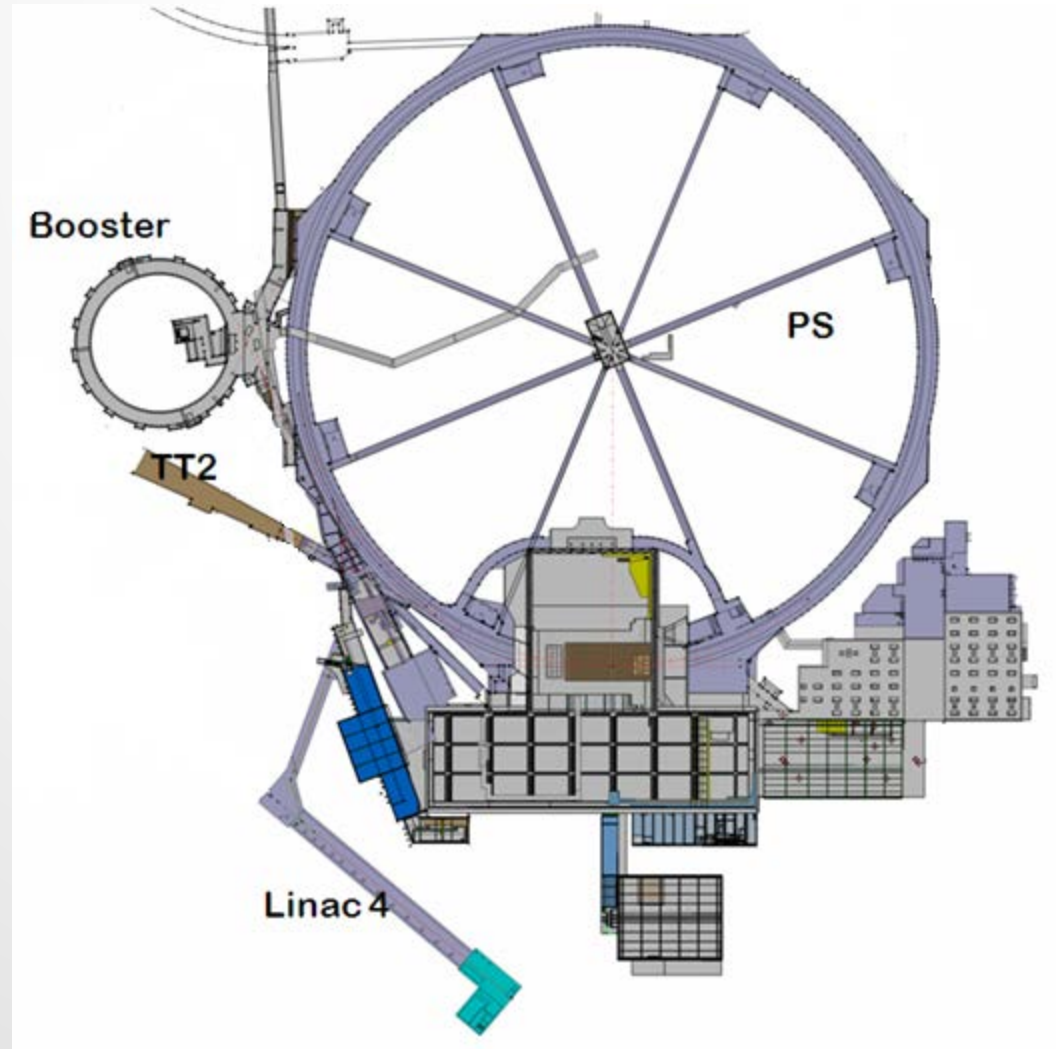
Michael Sordet BE-BI-PI
Linac4 BPM, 06.12.2012

Presentation index

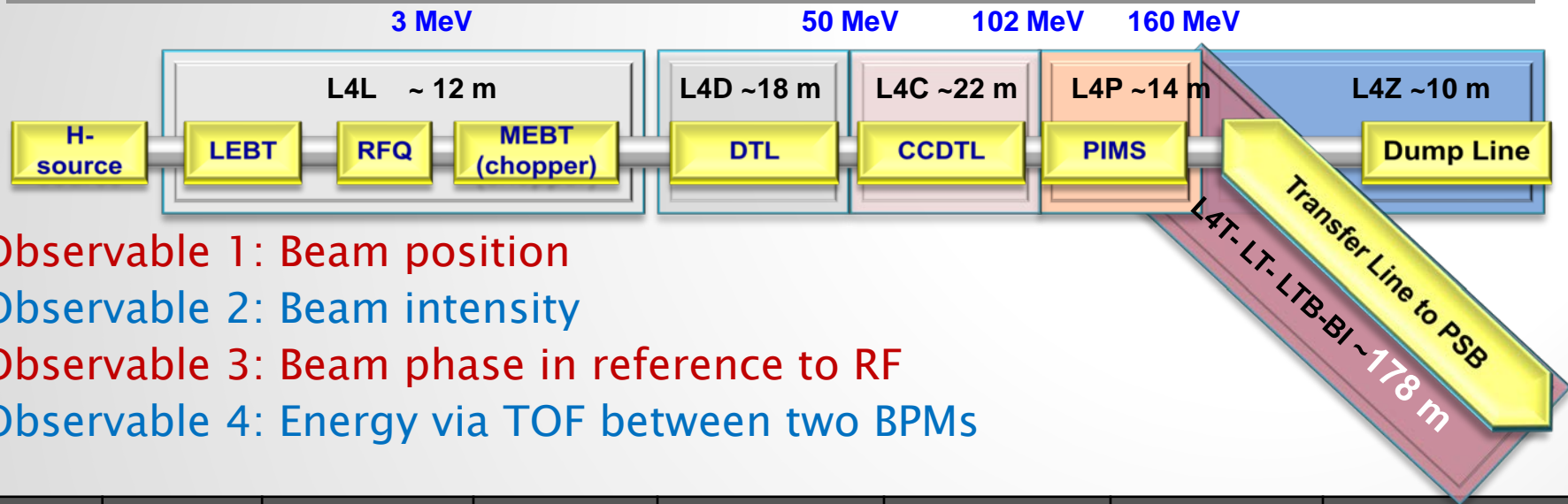
- ▶ Linac4 accelerator
- ▶ BPM on Linac4
- ▶ Mechanical details
- ▶ Electronic details
- ▶ Results
- ▶ To-do list
- ▶ Conclusion
- ▶ Questions

Linac4 accelerator

- ▶ Ion species H^-
- ▶ Output energy 160MeV
- ▶ Bunch frequency 352.2MHz
- ▶ Max. repetition rate 2Hz
- ▶ Beam pulse length $400\mu s$
- ▶ Mean pulse current 40mA
- ▶ Number of particles per bunch $1.14 \cdot 10^9$



BPM layout and specs for Linac4



Observable 1: Beam position

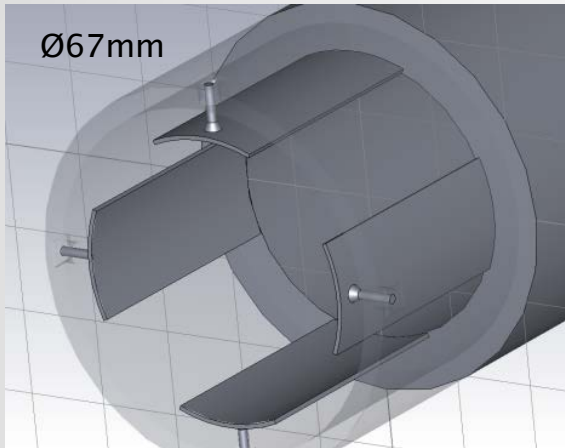
Observable 2: Beam intensity

Observable 3: Beam phase in reference to RF

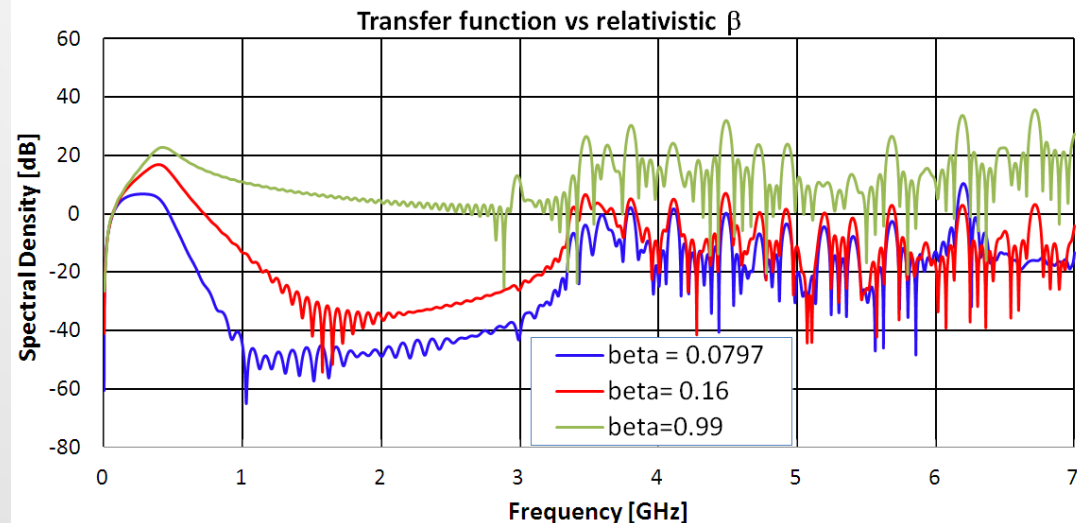
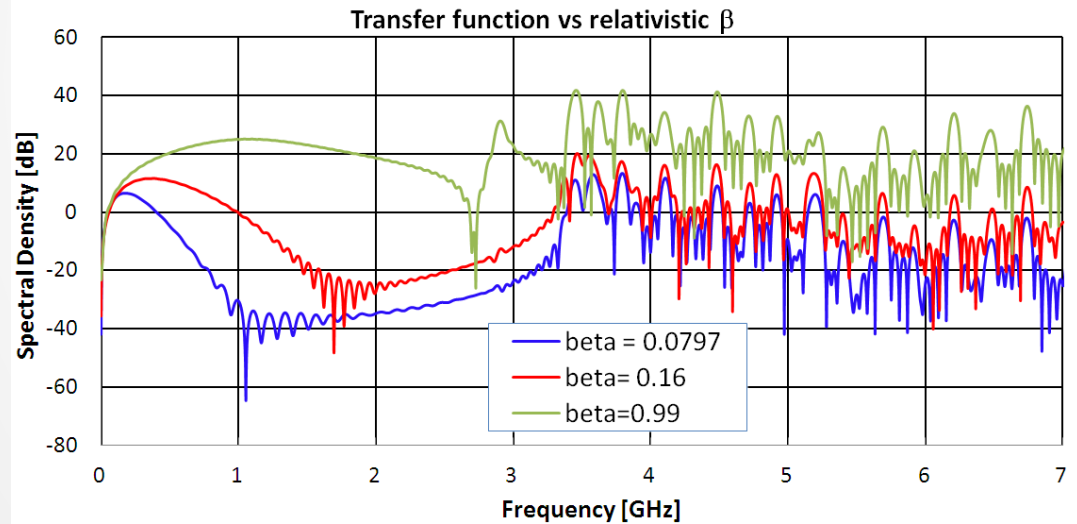
Observable 4: Energy via TOF between two BPMs

Line	# of Monitors	Beam position Resolution	Beam position Accuracy	Rel. Beam Intensity Resolution	Beam phase Resolution	TOF Resolution	Comments
L4D	2	0.1 mm	0.3 mm	1% of peak current	0.5°	1 per thousand	Ø34mm
L4C	7						Ø39mm
L4P	6						Ø39mm
L4T to PSB	10+17						Ø100 + 140mm

Transfer function of the test stand BPM

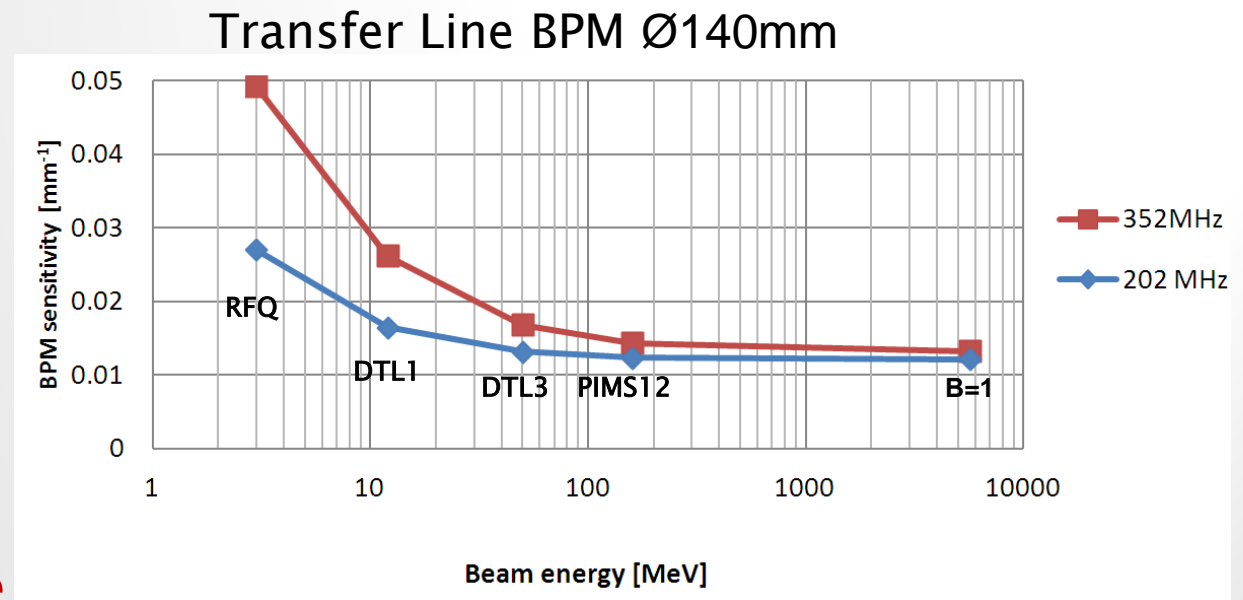


- ▶ Shorted stripline with added capacitance
- ▶ Linear on working range
- ▶ Better for linear phase measurement
- ▶ β -dependent



Dealing with low- β beams

- ▶ PU sensitivity changes with β
- ▶ These simulations confirm Shafer's theorem (1994)
- ▶ The values obtained from the simulations will be implemented in the software



Many different BPM variants

DTL

- Beam aperture: 34 mm
- Electrode length: 117 mm



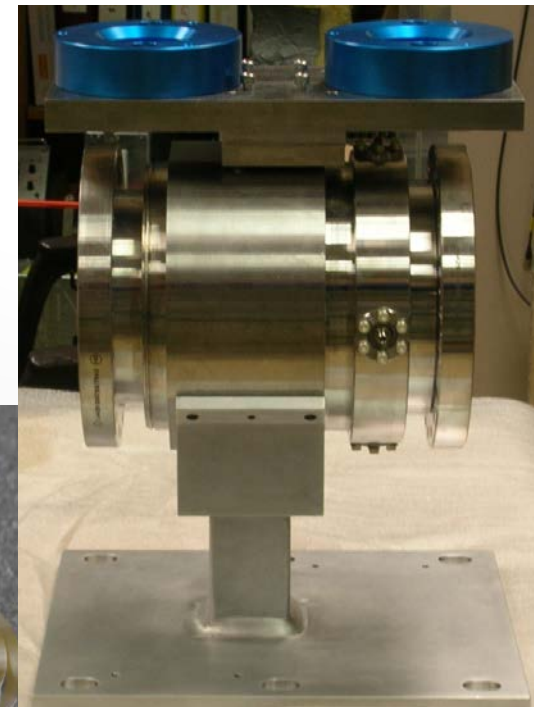
3MeV

- Beam aperture: 60mm
- Electrode length: 67mm



TRANSFER LINE

- Beam aperture: 100 mm
- Electrode length: 140 mm



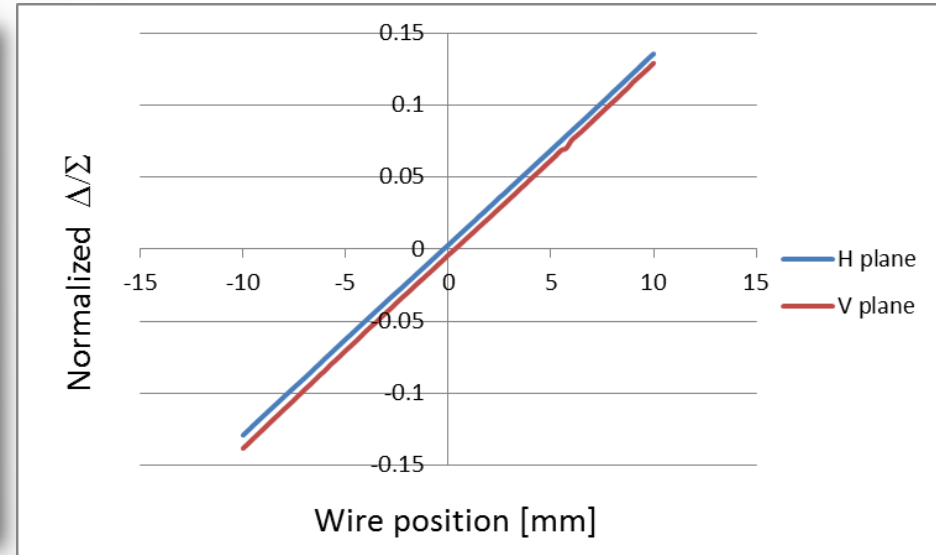
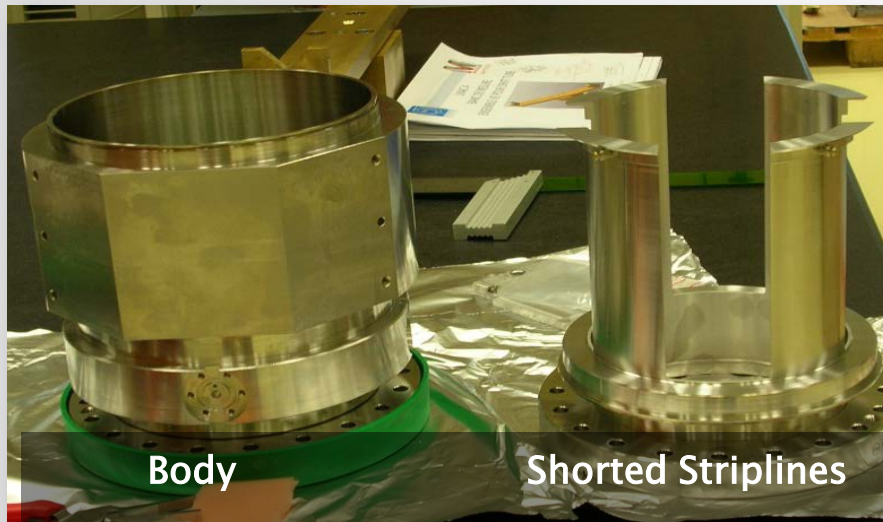
Lab test bench

- ▶ Wire technique with standing waves
- ▶ Optical sensor for mechanical centering : ± 0.01 mm
- ▶ 352MHz sine wave with a N.A.
- ▶ Data acquisition with steps of 0.1 mm
- ▶ Gives sensitivity and electrical offset



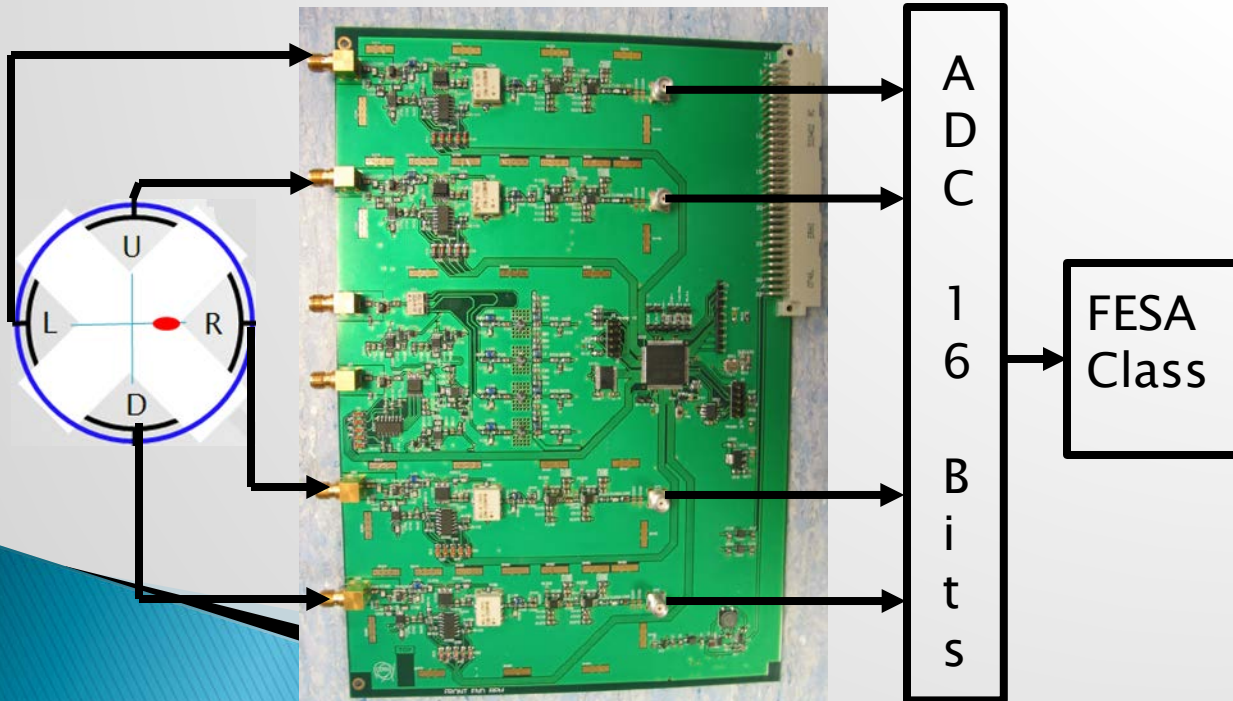
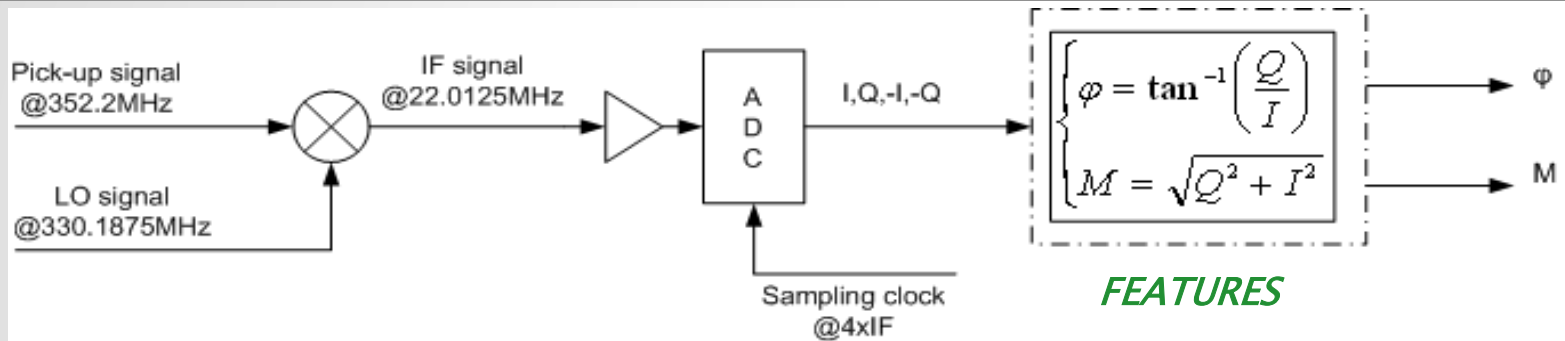
BPM sensitivity at 352MHz

Transfer Line BPM Ø140mm



@352MHz	Simulations	H plane	V plane
Sensitivity[mm]	75.4	75.88	75.24
Elec. Offset [mm]	-	-0.31	0.34

Acquisition chain



- ▶ Input Low pass filtering @1GHz
- ▶ Down-mixing with LO
- ▶ Variable gain selection
- ▶ Band-pass filtering @22MHz
- ▶ FPGA for calibration and gain control
- ▶ Sampling frequency = 4x IF
- ▶ ENOB ADC 13.4 bits
- ▶ LSB ADC 76 μ V

Signal processing

- ▶ Phase and intensity calculation with I/Q sample per channel

$$M_1 = \frac{1}{A_1} \cdot \sqrt{I_1^2 + Q_1^2}$$

$$\varphi_1 = \tan^{-1} \left(\frac{Q_1}{I_1} \right) + P_1$$

- ▶ Calculation for each PU

- Position

$$\Delta H = S_h \cdot \frac{M_1 - M_2}{\sum M_i} + offset_h$$

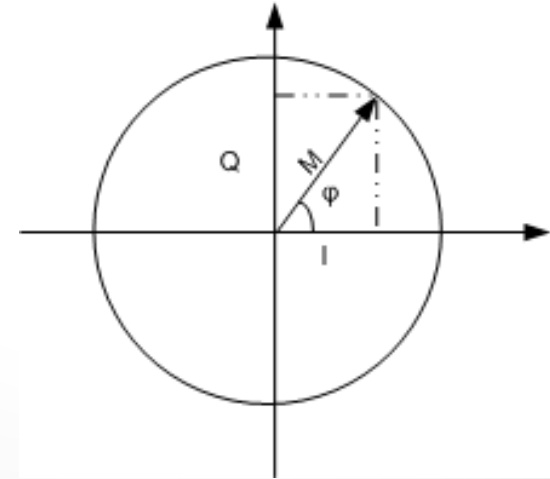
- Phase

$$\varphi_{tot} = \frac{\varphi_1 + \varphi_2 + \varphi_3 + \varphi_4}{4}$$

- Intensity

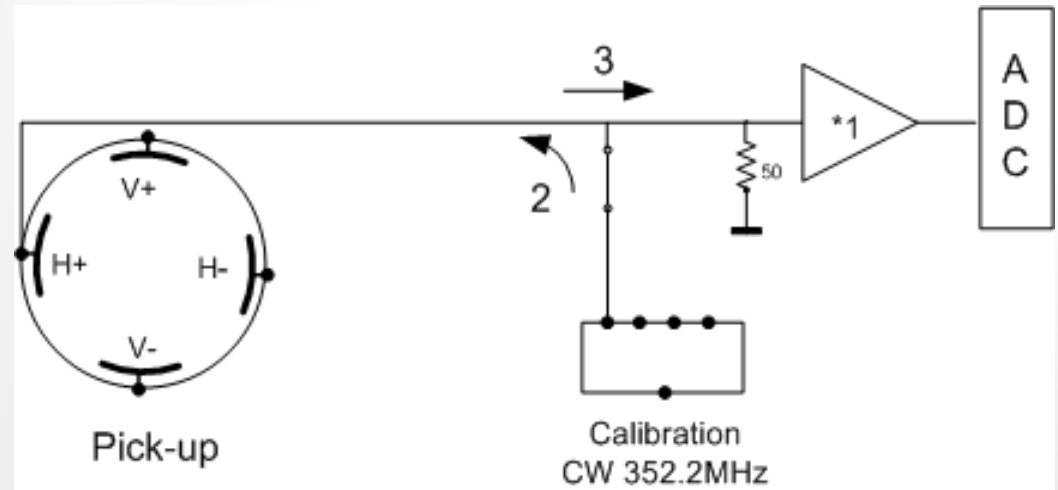
$$I = \frac{\sum M_i}{Z_t}$$

Z_t : transfer impedance



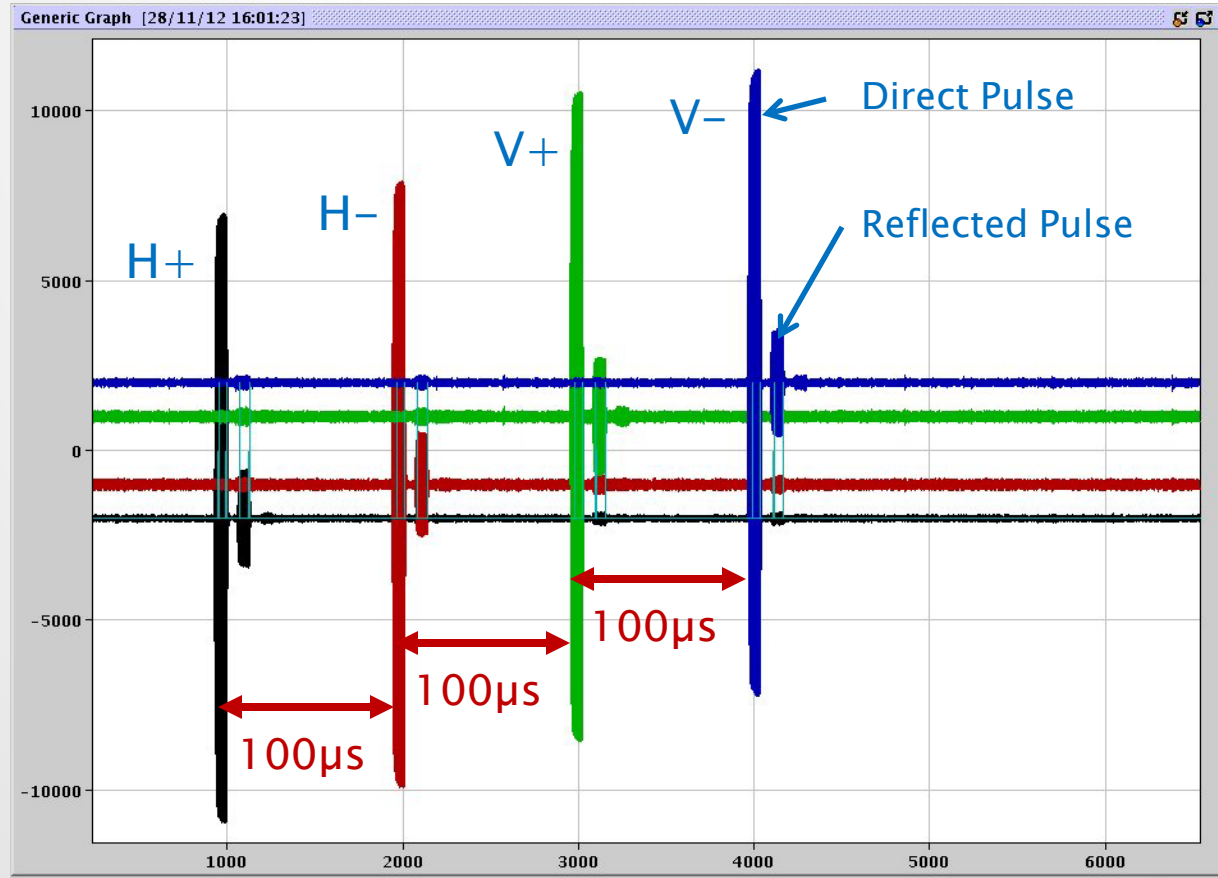
Calibration procedure

- ▶ **Set the phase and the gain per channel**
 - ▶ Inject sine wave into the direct channel(1)
 - ▶ Numerical gain and phase correction
- ▶ **Set the length of cables per PU**
 - ▶ Inject sine wave into the cable(2)
 - ▶ Signal back after reflection on the PU(3)
 - ▶ Numerical gain and phase correction



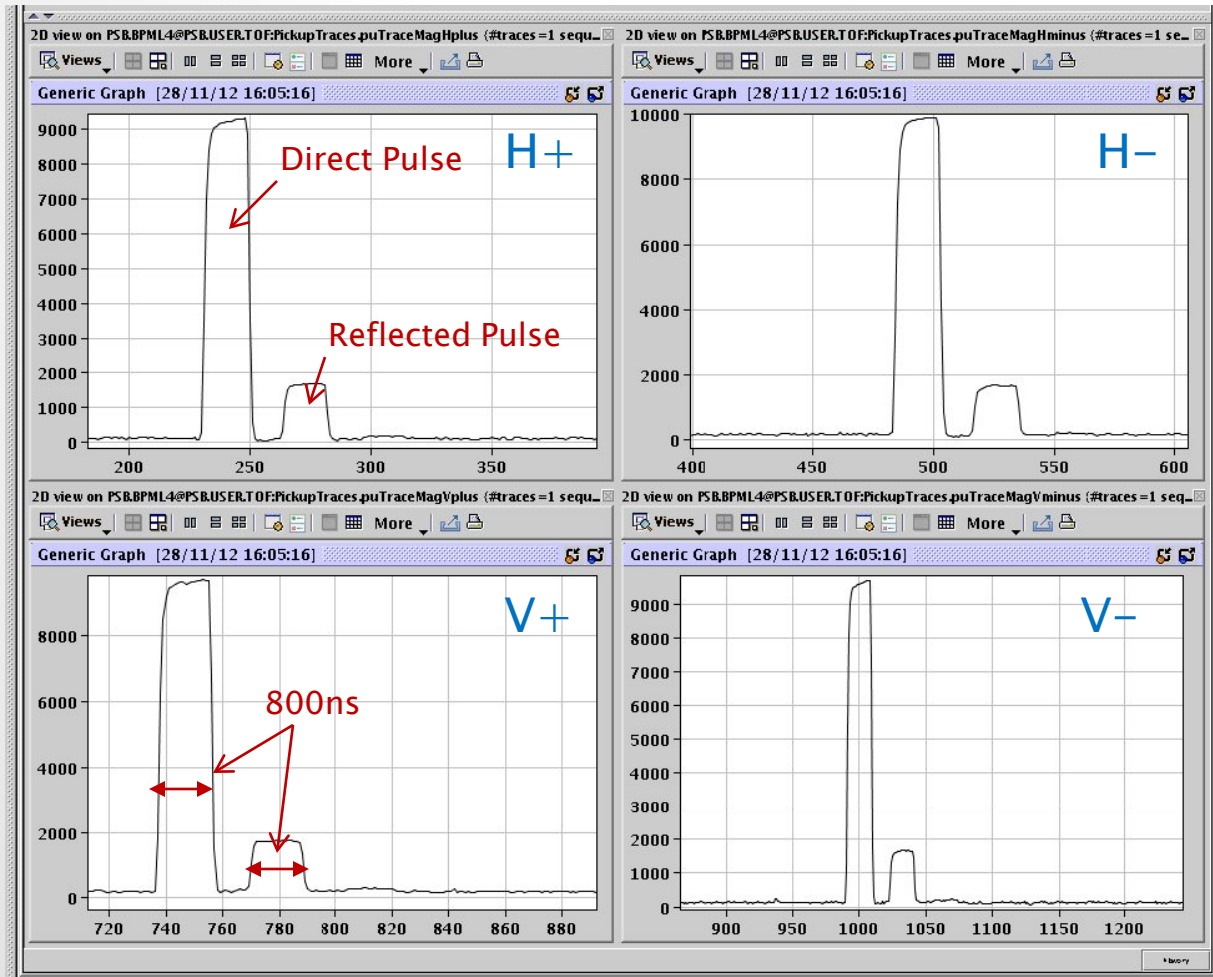
Calibration : raw data

- ▶ 4 electrode-calibration
- ▶ Each channel space with $100\mu\text{s}$
- ▶ Direct and reflected sine wave pulse
- ▶ I/Q sample series
- ▶ With artificial offset

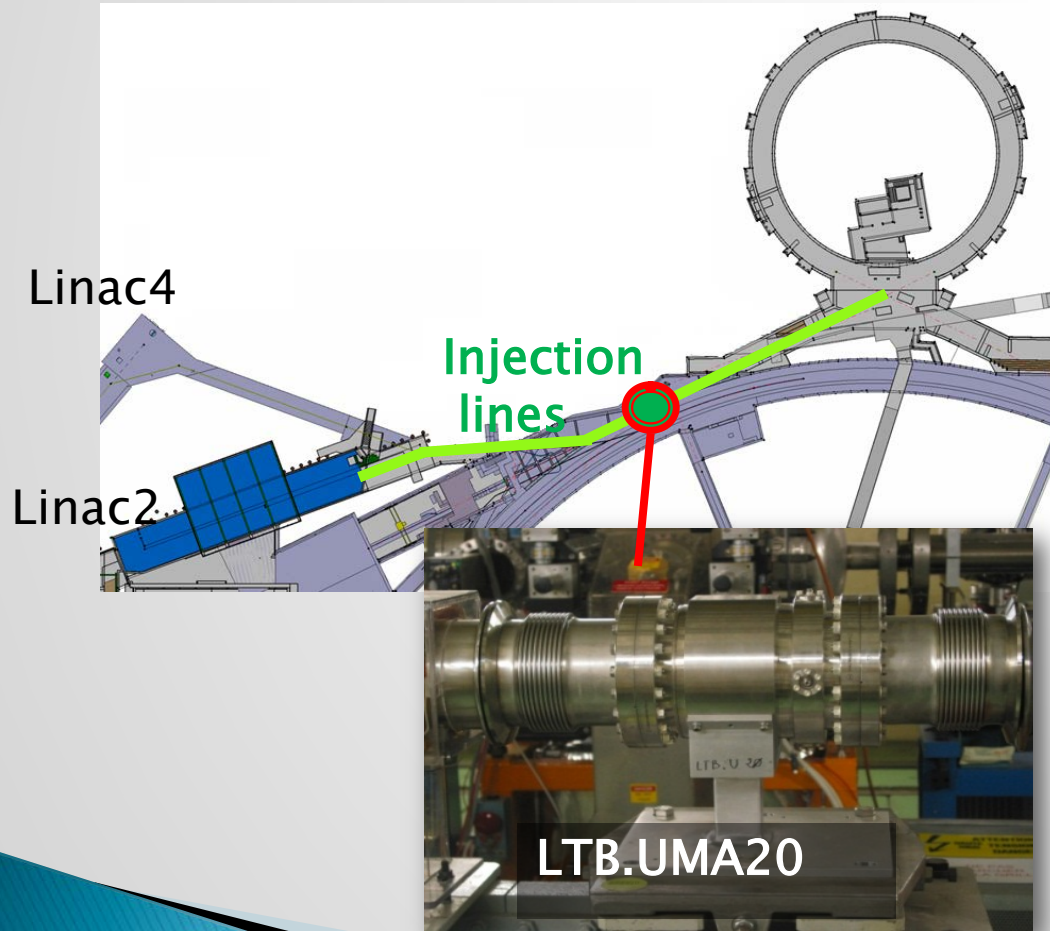


Calibration : processed data

- ▶ 4 electrode-calibration
- ▶ Direct and reflected sine wave train
- ▶ One magnitude point for one quadruplet (I,Q,-I,-Q)
- ▶ Gives a set of scaling factors per electrode: [Amplitude, Phase] $[A_{1..4}, P_{1..4}]$



Commissioning with proton beam



- ▶ Transfer lines from Linac-2 to Booster
- ▶ Upgrade with Linac4 type BPM : shorted stripline (present BPMs are 40 years old)
- ▶ Status : commissioning of one monitor with protons since Sept. 2012
- ▶ Bunching frequency 202MHz

First raw beam data

- ▶ TOF beam
- ▶ 4 channels
- ▶ Electronics card output
- ▶ Difference between simulation and real life : Amplitude is 45% less than expected



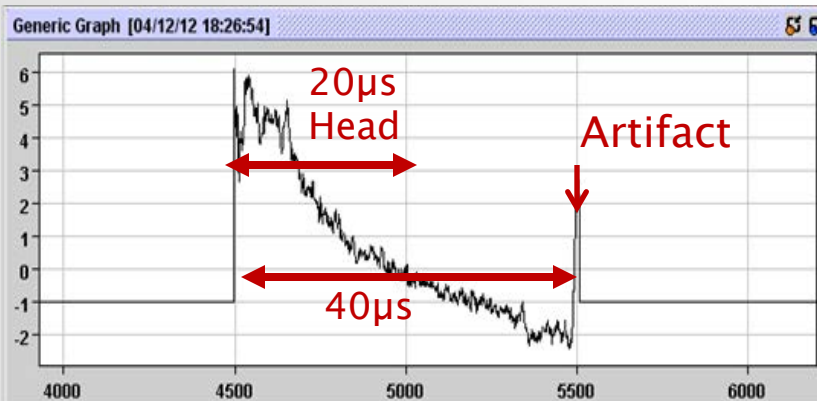
Position measurement

TOF beam

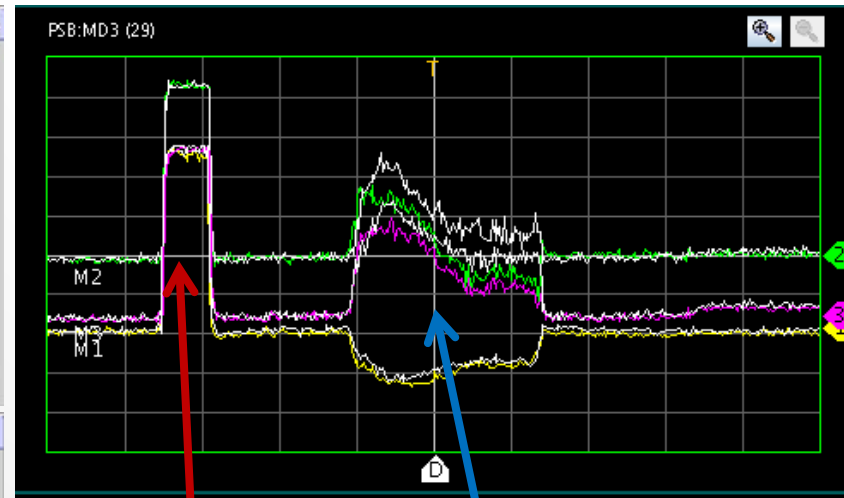
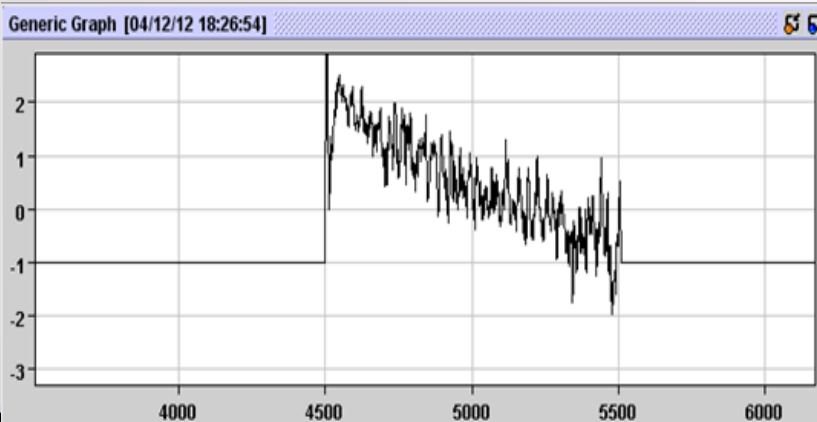
▶ New BPM measurement

▶ Old BPM measurement

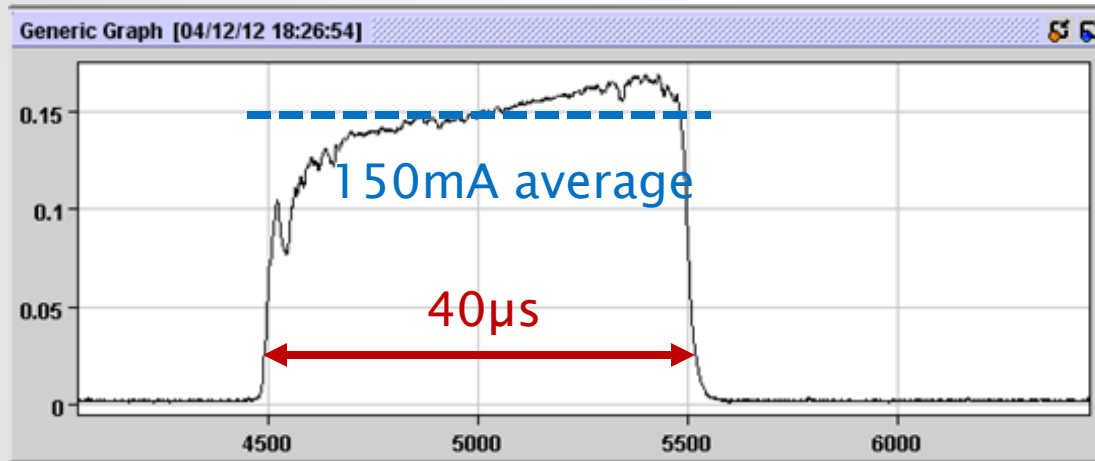
▶ Horizontal position



▶ Vertical position



Intensity measurement



▶ BPM measurement

▶ TOF beam

▶ Beam current [A]

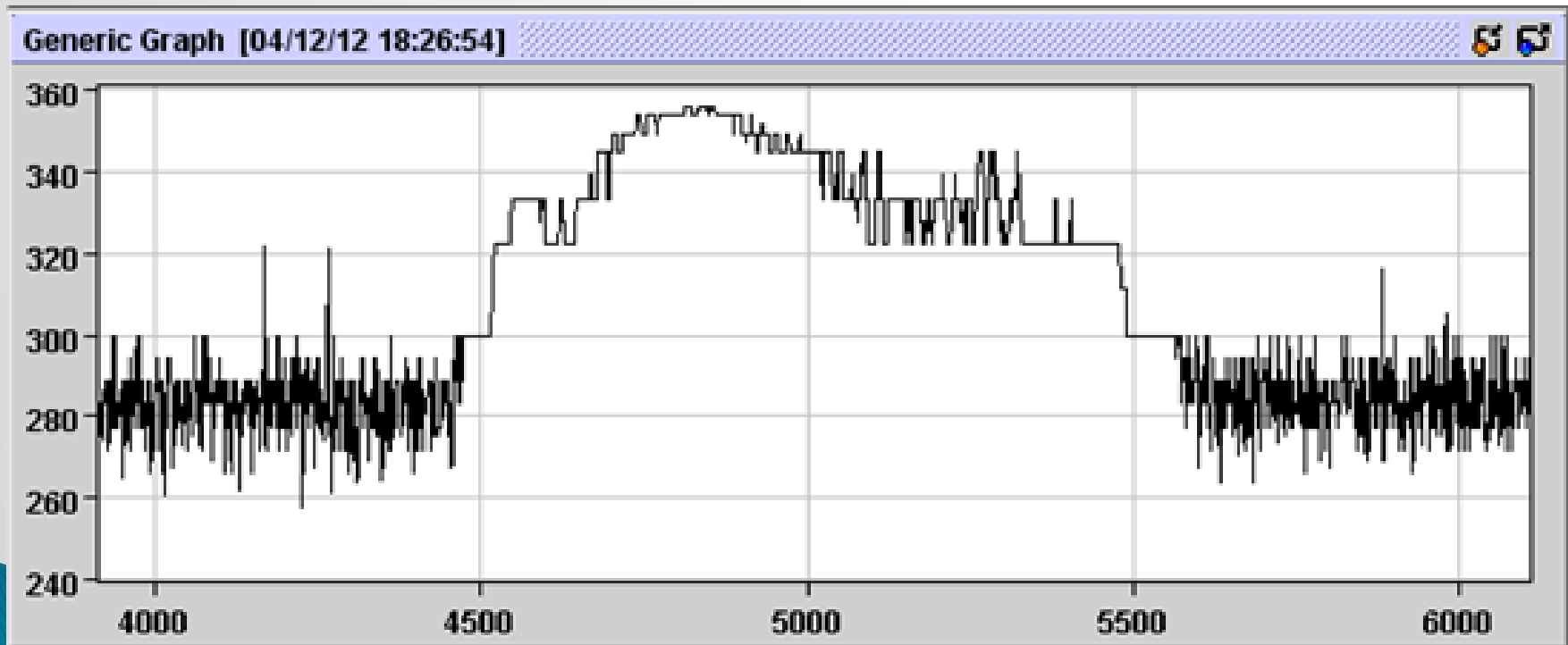
▶ Calibrate with BCT



▶ BCT measurement

Phase measurement

- ▶ First phase measurement
- ▶ 5° phase jump
- ▶ Phase between one BPM and the RF reference



To-do list

- ▶ Finish commissioning test with the LTB-UMA-20
- ▶ Be ready for H⁻ beam in the 3MeV test stand in January 2013
- ▶ LS1 change all the old L2 BPM and install new acquisition system
- ▶ Be ready for H⁻ beam test in L4 tunnel in September 2013

Summary and conclusion

- ▶ Encouraging first results with beam
- ▶ Very useful test with Linac2 for the future commissioning of the Linac4
- ▶ Not expected position measurement excursion, we need to do a MD to test that
- ▶ Intensity measurement with 45% less signal at the output of the BPM
- ▶ 5° phase jump for phase measurement to be understood and corrected

Acknowledgements

- ▶ Project leader Jocelyn Tan
- ▶ Michael Ludwig for the software
- ▶ Delphine Gerard for the mechanics
- ▶ RF group
- ▶ All the BI-PI section
- ▶ Drawing office EN/MME

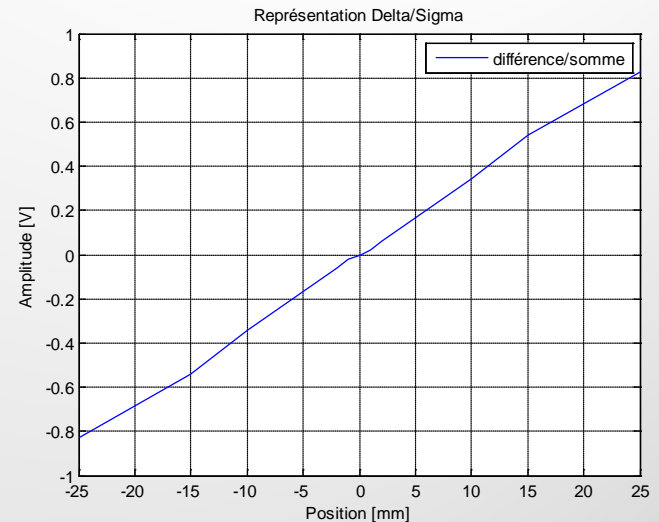
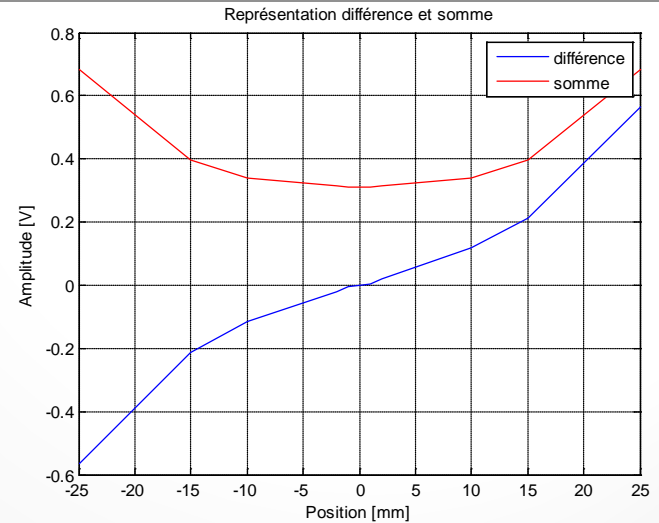
Thank you for your attention

QUESTIONS ???

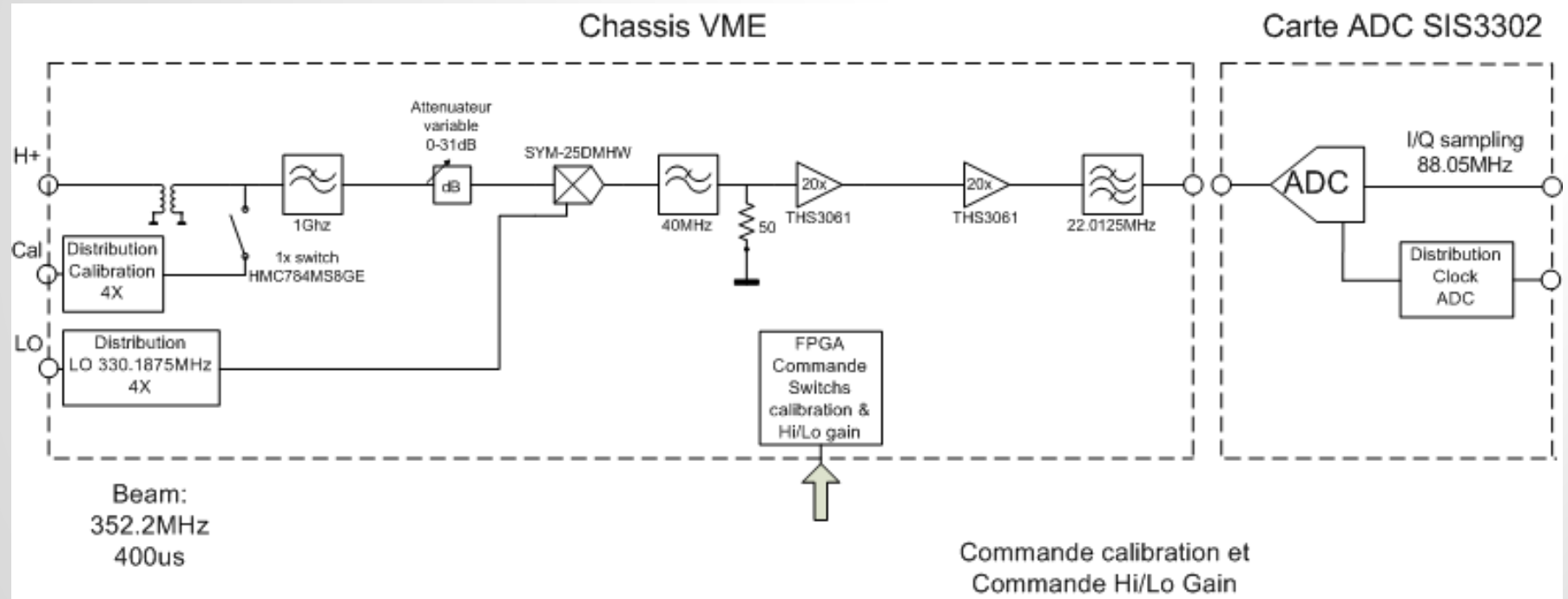
Extra Slide

Sensibility measurement

- ▶ Constant sum between ± 15 mm
- ▶ Linear difference between ± 15 mm
- ▶ Linear electrodes between ± 15 mm
- ▶ The PU is linear on the desired range

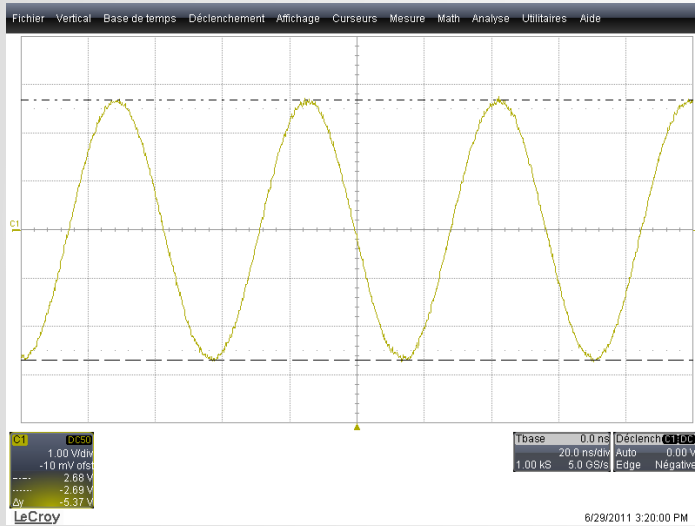


Analog card block diagram

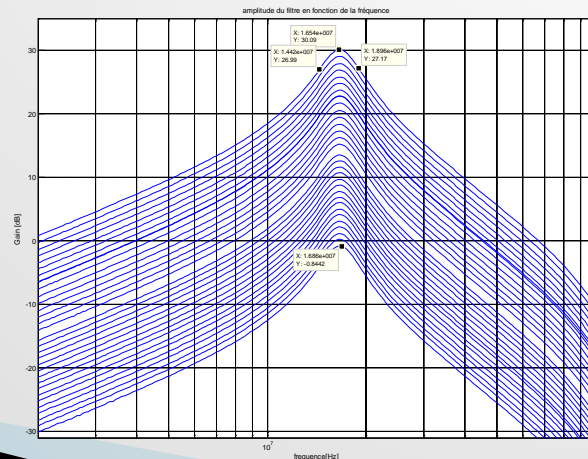
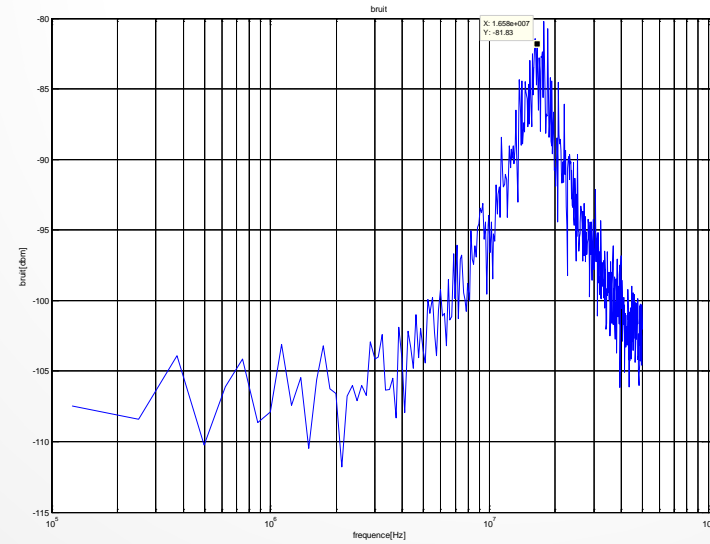


Lab measurement

Dynamic range



Noise measure

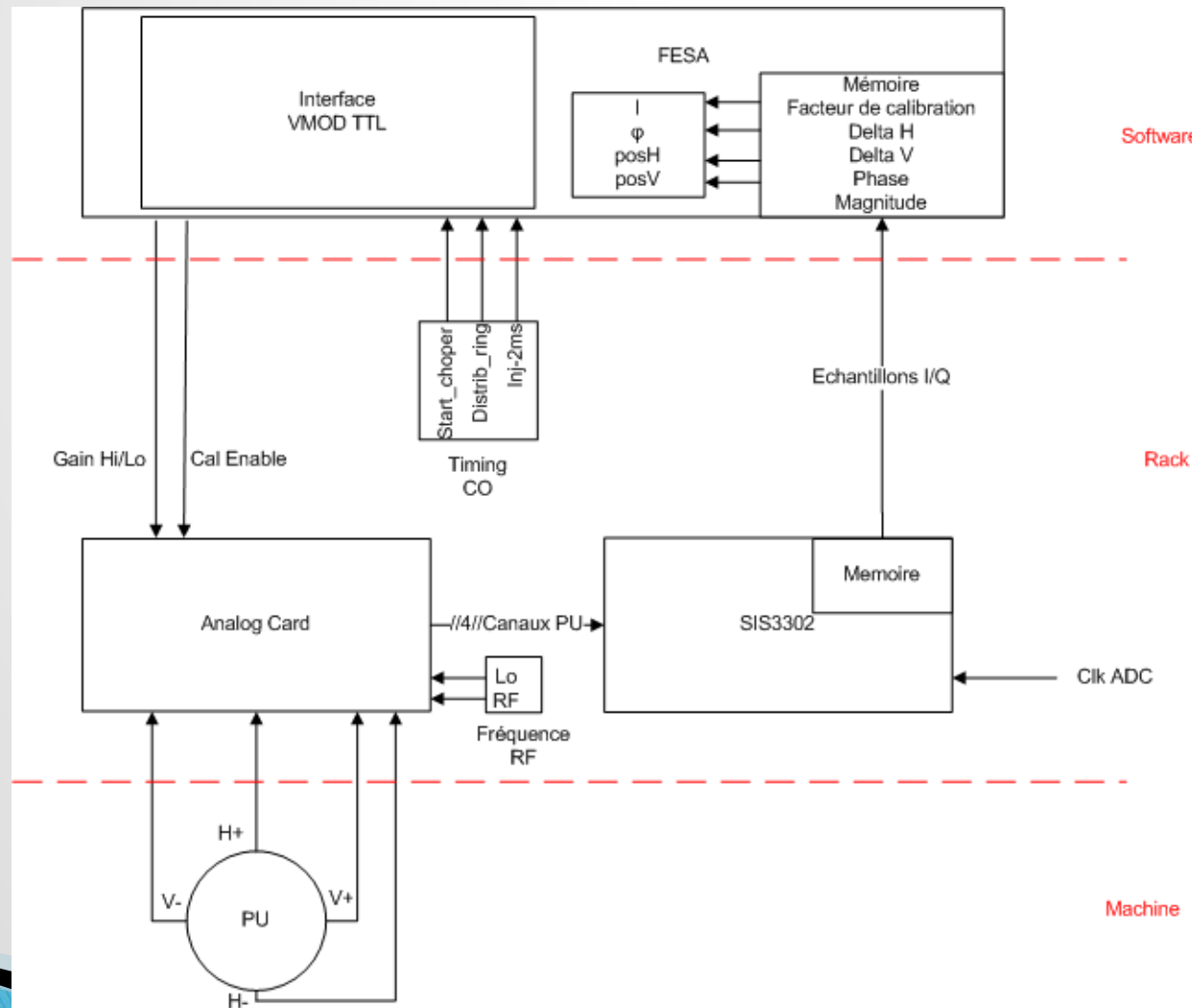


Gain & Bandwidth

Analog board characteristics

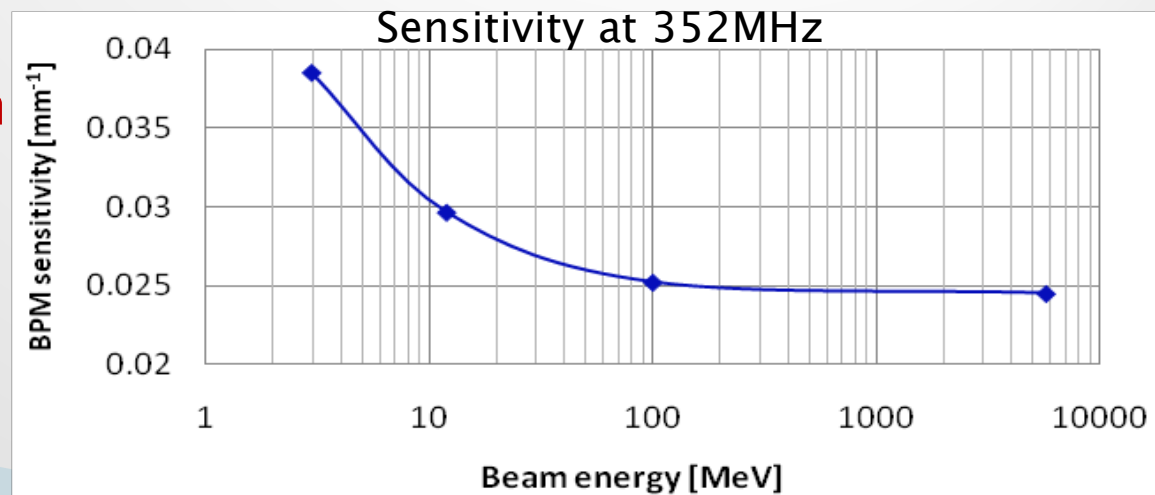
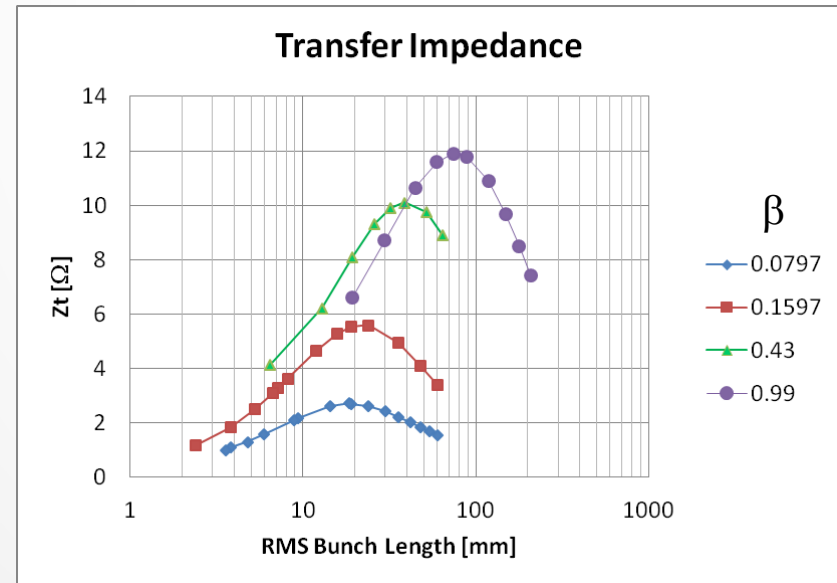
	Measure
Gain	0dB to 30.8 dB
Central frequency	22.01 MHz
Bandwidth	10 MHz
Output range	± 2.68 V
Output thermal noise	700 μ V
Crosstalk Signal Cal to IF 22 MHz	-50.4 dBm/0.7mV
Crosstalk LO 330 MHz	-57.2 dBm/0.3mV

Acquisition chain



Dealing with low- β beams

- ▶ Transfer impedance changes with β and bunch length
- ▶ PU sensitivity changes with β
- ▶ These simulations confirm Shafer's theorem (1994)
- ▶ The values obtained from the simulations will be implemented in the software



Intensity and position measurement

